



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q67546

Osamu NOZAWA

Allowed: December 10, 2003

Appln. No.: 09/998,422 ✓

Group Art Unit: 1756

Confirmation No.: 5963

Examiner: ROSASCO, STEPHEN D

Filed: December 3, 2001

For: LITHOGRAPHY MASK BLANK AND METHOD OF MANUFACTURING THE SAME

**AMENDMENT UNDER 37 C.F.R. §1.312**

**MAIL STOP ISSUE FEE**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Pursuant to the provisions of 37 C.F.R. §1.312, please amend the above-identified application as follows on the accompanying pages.